

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DT04 Rec'd PCT/PTO

10/511557

15 OCT 2004

Applicant(s): Mund & Leib
Serial No.: Not Yet Assigned
Filed: Herewith
For: PROCESS FOR JOINING SUBSTRATES, & COMPOSITE
ELEMENT
Art Unit: Not Yet Assigned
Examiner: Not Yet Assigned
Confirmation No.: Not Yet Assigned
Customer No.: 27623

Attorney Docket No.: 2133.062USU

Date: October 15, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with applicants' duty of disclosure under 37 C.F.R. §1.56, we are enclosing form PTO-1449 listing information that may be material to the patentability of this application.

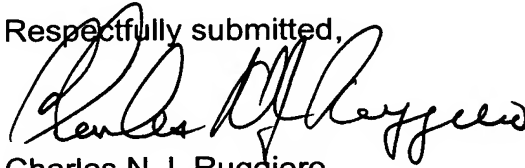
It should be understood that attention has been called to the citations that have been deemed to be pertinent to the claimed present invention. In concluding what was pertinent, the criteria employed was considered most appropriate in light of the invention shown in the present application. However, the Examiner or others may deem some other criteria to be just as appropriate or more appropriate. Therefore, the

Examiner is respectfully urged to review the listed citations and to make the usual careful independent search for other prior art that may be pertinent.

Since this Information Disclosure Statement is being filed with the filing of this application, no petition or fee is required.

Applicants respectfully request favorable consideration and that this application be passed to allowance.

Respectfully submitted,



Charles N.J. Ruggiero

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Attorney for Applicant(s)

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FORM PTO-1449

Docket Number (Optional)

2133.062USU

Application Number

Not Yet Assigned

107511557

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Applicant

Mund and Leib

Filing Date

Herewith

Group Art Unit

Not Yet Assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,895,233	4/20/99	Higashi et al.	438	107	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	0 280 905 A2	9/7/88	Europe			X	
	DE10222609.1A1	5/23/02	Germany				X
	DE10222958.9A1	5/23/02	Germany				X
	DE10222964.3A1	5/23/02	Germany				X
	DE10252787.3A1	11/13/02	Germany				X
	DE10301559.0A1	10/30/03	Germany				X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

	XP-10232226A-1, Anodic Bonding Technique Under Low-Temperature and Low-Voltage Using Evaporated Glass, Woo-Beom Choi et al., 9 th Int'l Vacuum Microelectronics Conference, St. Petersburg 1996, pgs 427-430

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.